

MNE 2006

Plenary Sessions

NAME	TITLE	PAPER REF.
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Monday, September 18th

Session PL 1

Auditorium

09:30-10:15	M. Sasago	Where are the limitations of 193 nm immersion lithography?	PL1-1
10:15-11:00	L. Samuelson	Novel applications based on nanowires	PL1-2

Tuesday, September 19th

Session PL 2

Auditorium

09:00-09:45	H. Craighead	Nanostructures for biomolecular analysis	PL2-1
09:45-10:30	C. T.-C. Nguyen	Towards LSI vibrating micromechanical signal processors	PL2-2

Session PL 3

Auditorium

15:00-15:45	S. Williams	Computing at the nanoscale	PL3-1
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Session PL 4

Auditorium

09:00-09:45	J. Bokkor	Emerging Nanoelectronics in Mainstream Information Processing Systems	PL4-1
09:45-10:30	P. Kruit	The role of MEMS in maskless lithography	PL4-2